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# **Optimum Device Parameters and Scalability of Variable Threshold CMOS (VTCMOS)**

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# 1. Introduction

Variable threshold voltage CMOS (VTCMOS) is one of the most promising device/circuit schemes for low power VLSI applications [1-3]. The threshold voltage ( $V_{th}$ ) is shifted by substrate bias ( $V_{bs}$ ) using body effect, and high  $V_{th}$  in the stand-by mode and low  $V_{th}$  in the active mode are attained. The  $V_{th}$  shift ( $\Delta V_{th}$ ) is given by

$$\Delta V_{th} = \gamma \,|\, \Delta V_{bs} \,|\,, \tag{1}$$

where  $\gamma$  is the body effect factor [4,5]. Therefore,  $\gamma$  and  $\Delta V_{bs}$  are the most important device parameters in VTCMOS. However, the optimum device design for VTCMOS has not been generally recognized and the scalability of VTCMOS is an issue of great concern for future applications. In this study, the optimum device design for VTCMOS is systematically investigated by device simulation and the scalability of VTCMOS is discussed. It is suggested that, while VTCMOS aiming at ultra-low stand-by current does not maintain its advantage as the device and the supply voltage are scaled, VTCMOS will be an essential device/circuit scheme aiming at high-speed applications.

### 2. Characteristics of VTCMOS

The main target of VTCMOS is to reduce the stand-by current ( $I_{off}$ ) while maintaining the circuit speed ("low power mode"). When the stand-by current is fixed, on the other hand, the on-current ( $I_{on}$ ) can be enhanced by body effect in VTCMOS [5] ("high-speed mode"). The characteristics of these two modes are illustrated in Fig. 1. In order to investigate the VTCMOS performances, two dimensional device simulation [6] is performed assuming uniformly doped, delta-doped, and counter doped MOS-FETs [5]. The device parameters are based on the International Technology Roadmap for Semiconductors (ITRS) [7]. Fig. 2 shows the dependences of VTCMOS characteristics on  $\gamma$  and  $|\Delta V_{bs}|$  at the 180 nm technology node. It is suggested in both modes that

(1)  $|\Delta V_{bs}|$  should be set as large as the junction leakage permits.

(2) When the values of  $\gamma$  and  $V_{th}$  can be designed at a fixed  $V_{bs}$ , the optimum  $\gamma$  depends on the relationship between supply voltage ( $V_{dd}$ ) and  $|\Delta V_{bs}|$ .

At the 180 nm technology node,  $V_{dd}$  is sufficiently high and both low power mode and high-speed mode can be attained.

#### 3. Scaling of VTCMOS

When the device size and  $V_{dd}$  are scaled, the VTCMOS characteristics significantly differ from the 180 nm technology node. Three scaling scenarios are shown in Fig. 3 and required  $|\Delta V_{bs}|$  is shown in Fig. 4.

3.1. Low power mode: In the battery-operated portable system, the stand-by current should be less than 0.1 pA/ $\mu$ m. Then, V<sub>th</sub> in the stand-by mode should be higher than 0.5 V

and  $\Delta V_{th}$  should be larger as  $V_{dd}$  is scaled (Scenario A), as shown in Fig. 3. Required  $|\Delta V_{bs}|$  increases rapidly and would exceed breakdown voltage, as shown in Fig. 4. The scaling scenario of low power mode will fail in the future.

3.2. High-speed mode: On the other hand, the advantage of VTCMOS will be kept even when  $\Delta V_{th}$  is constant (Scenario B) or is reduced (Scenario C), because on-current enhancement is determined by  $\Delta V_{th} / V_{dd}$ . While Scenario B will fail due to constant  $|\Delta V_{bs}|$ , Scenario C where the current enhancement ratio ( $\Delta I_{on}/I_{on}$ ) is constant will take full advantage because required  $|\Delta V_{bs}|$  is reduced in proportion to  $V_{dd}$ . Fig. 5 shows the dependences of VTCMOS characteristics on  $\gamma$  and  $|\Delta V_{bs}|$  at the 35 nm technology node in Scenario C. To reduce the junction leakage current by back-bias, positive  $V_{bs}$  is applied. The positive  $V_{bs}$  will become very effective when V<sub>dd</sub> is scaled down to lower than 0.6 V. Forwarded pn-junction current is negligible because it flows in Scenario C can attain high the enhancement mode. on-current in the enhancement mode while suppressing the off-current in the normal mode.

# 4. Device/Circuit Scheme in the future

In VTCMOS in the high-speed mode (Scenario C), the stand-by power will be huge and we certainly need another measure to suppress the stand-by current. Fig. 6 shows a schematic of the device/circuit scheme where high-speed mode VTCMOS is combined with leak cut-off switch such as BGMOS [8] and SCCMOS [9]. The high-speed scheme and the low stand-by scheme should be merged when the device and  $V_{dd}$  are scaled in the future.

#### 5. Conclusion

The optimum device parameters and scalability of VTCMOS have been discussed. Although the scaling scenario of low stand-by current VTCMOS will fail, high-speed VTCMOS will take advantage in the combination with a low stand-by scheme.

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Fig. 1. modes be enhanced compared with that in stand-by mode gives smaller Ioff, standby, which is similar to the high-speed mode. (Ion,standby).

Schematics of VTCMOS characteristics in the two Fig. 2. VTCMOS characteristics as a function of  $\gamma$  and  $|\Delta V_{bs}|$  at the 180 nm (a) Low power mode where Ioff is reduced while technology node. (a) High-speed mode. Ioff, standby is fixed to the constant maintaining  $I_{on}$ .  $I_{off}$  in the stand-by mode ( $I_{off,standby}$ ) is value (0.1 pA/µm).  $V_{bs,active} = 0$  V in this case. When  $|\Delta V_{bs}|$  is small, a desuppressed compared with that in the active mode ( $I_{off,active}$ ) vice with smaller  $\gamma$  gives larger  $I_{on,active}$  than that with larger  $\gamma$ . In contrast, using body effect.  $V_{bs}$  in the active mode ( $V_{bs,active}$ ) is 0 V when  $|\Delta V_{bs}|$  is large, a device with larger  $\gamma$  gives larger  $I_{on,active}$  although  $I_{off,active}$ in this study. (b) High-speed mode where  $I_{on}$  is enhanced also increases. (b) Low power mode.  $I_{on,active}$  is fixed to the constant value while maintaining  $I_{off}$ .  $I_{on}$  in the active mode ( $I_{on,active}$ ) can (1 mA/µm).  $V_{bs,active} = 0$  V. When  $|\Delta V_{bs}|$  is small, a device with smaller  $\gamma$ 





Fig. 3. Three scaling scenarios of VTCMOS. Scenario A: Ioff,standby is constant (= 0.1 pA/ $\mu$ m) (low power mode). Scenario B:  $I_{off,standby}/I_{off,active}$  is constant (= 0.01) (high-speed mode). Scenario C: current enhancement  $\Delta I_{off}/I_{on}$  is constant (= 0.2) (high-speed mode).  $I_{on,active}$  is set to 750  $\mu$ A/ $\mu$ m and  $V_{bs,active} = 0$  V in all cases. Uniformly doped MOSFETs are assumed. Device parameters at each technology node are based on ITRS. (a) Relationship between  $I_{on}$  and  $I_{off}$ . (b) Relationship between  $V_{dd}$  and  $\Delta V_{th}$ .  $\Delta V_{th}$  rapidly increases in Scenario A.  $\Delta V_{th}$  is roughly constant in Scenario B.  $\Delta V_{th}$  decreases in proportion to  $V_{dd}$  in Scenario C.

Fig. 4. Required  $|\Delta V_{bs}|$  in three scenarios at each technology node. Broken lines show the simulation results for uniformly doped MOS-FETs, where y decreases as the device is scaled. Solid lines show devices with constant short channel effect ( $\gamma = 0.2$ ). Even in the latter case, Scenarios A and B will fail due to large I V hsl compared with V<sub>dd</sub>.



Fig. 5. VTCMOS characteristics in the high-speed mode as a function of  $\gamma$  and  $|\Delta V_{bs}|$  at Fig. 6. A device/circuit scheme in the future, the 35 nm technology node. Here, the two modes are denoted by enhancement and normal where the high-speed VTCMOS and leak cut-off modes, instead of active and stand-by modes. Positive  $V_{bs}$  is applied in the enhancement switch such as BGMOS [8] or SCCMOS [9] are mode and  $V_{bs}$  in the normal mode  $(V_{bs,normal})$  is set to 0 V.  $I_{off}$  in the normal mode combined. VTCMOS enhances  $I_{on}$  and leak  $(I_{off,normal})$  is fixed to 160 nA/µm. When  $|\Delta V_{bs}|$  is sufficiently large,  $I_{on}$  in the enhancement cut-off switch reduces  $I_{off}$ . mode (Ion,enhance) increases dramatically, although Ioff,enhance also increases.